

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1746

PATENT APPLICATION
Docket No.: 2522-042
Client Ref. No.: AW8122US/PJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Eun-Taek YIM, et al.

Serial No.: 10/734,479

Examiner: Chaudry, Saeed T.

Filed: December 12, 2003

Art Unit: 1746

Confirmation No.: 9601

For: METHOD FOR CLEANING A DEPOSITION CHAMBER AND
DEPOSITION APPARATUS FOR PERFORMING IN SITU
CLEANING

Date: November 20, 2006

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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*Entry
Jan 11/29/06*

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 20060914, dated September 18, 2006,
please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 7 of this paper.